

Notice of References Cited	Application/Control No. 10/786,787	Applicant(s)/Patent Under Reexamination XIE ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	V	Zhang, Gang et al, A Lateral Capacitive CMOS Accelerometer with Structural Curl Compensation, , Proceedings of 12 th International Workshop on Micro Electro Mechanical Systems (MEMS'99), orlando, FL, USA; 17-21 Jan 1999, p 606-611.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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*	V ¹	Xie, Huikai et al, A CMOS-MEMS Lateral-axis Gyroscope, Technical digest of the 14 th IEEE International Conf. on Micro Eletro Mechanical Systems (MEMS '01), Interlaken, Switzerland, Jan. 21-25, 2001, pp 162-165.
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*	X ¹	Xie, Huikai et al, Vertical Comb-finger Capacitive Actuation and Sensing of CMOS-MEMS, Sensors and Actuators, vol. 95, issue 2-3, January 2002, pp212-221.

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